





IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

in Ke	tne	Application	OI:

JINNO et al.

Serial No.: 09/753,397

Filed: January 3, 2001

Atty. File No.: 2933SE-62-DIV

"THIN FILM TRANSISTOR AND For:

METHOD OF FABRICATING THE

SAME"

Commissioner of Patents Washington, D.C. 20231

Dear Sir:

Group Art Unit:

Examiner:

NOTICE OF CLAIM FOR FOREIGN PRIORITY BENEFITS UNDER 35 U.S.C. §119

CERTIFICATE OF MAILING

I HEREBY CERTIFY THAT THIS CORRESPONDENCE OR FEE IS BEING DEPOSITED WITH THE UNITED STATES POSTAL SERVICE AS FIRST CLASS MAIL IN AN ENVELOPE ADDRESSED TO ASSISTANT COMMISSIONER FOR PATENTS, WASHINGTON, D.C. 20231 ON THIS 21 DAY OF Feb., 2001.

SHERIDAN ROSS B.C.

As stated in the transmittal sheet submitted in connection with the above-identified patent application, foreign priority benefits are claimed under 35 U.S.C. §119 of Japanese Patent Application Serial No. 8-350619 filed December 27, 1996. Certified priority documents, which have been accepted by the U.S. Patent and Trademark Office, were filed in connection with the parent of the present patent application, U.S. Patent Application Serial No. 08/997,763 filed December 24, 1997. Applicants respectfully request that the Examiner acknowledge the claim for priority.

Respectfully submitted,

SHERIDAN ROSS P.C.

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Date: Februa 1, 200